

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/642,306	CHEN, MU-YU
	<b>Examiner</b> John Ricci	<b>Art Unit</b> 3714

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
206	349,373	8/19/05	2-
	379,759		